



# Air Force Research Laboratory



## An Experimental Investigation of Residual Stress Development in Selective Laser Melting of Ti-6Al-4V

N.C. Levkulich, Wright State University  
Nathan Klingbeil, Wright State University  
Joy Gockel, Wright State University  
John Middendorf, UTC  
S.L. Semiatin, Air Force Research Lab

26 October 2017

*Integrity ★ Service ★ Excellence*



# Acknowledgements



*A Century of Scientific Excellence. We Make it Possible!*

- **Adrian Dewald: Hill Engineering**
- **Joseph Walker: UTC**
- **Sathish Shamachary, Rick Riebel, and Travis Brown:  
Air Force Research Lab**
- **Karen Taminger, Stacey Baggs: NASA Langley**



# Outline



*A Century of Scientific Excellence. We Make it Possible!*

- **Motivation and background**
- **Materials and procedures**
- **Results**
- **Conclusions**
- **Future Work**



# Motivation



*A Century of Scientific Excellence. We Make it Possible!*

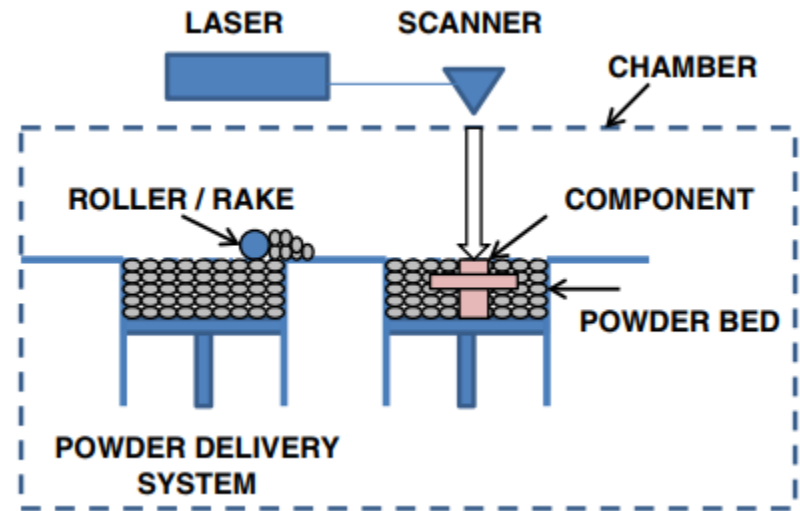
- **Advantages of Selective Laser Melting (SLM) Additive Manufacturing (AM) Compared to Other Processes:**

- Produces high resolution
- Complex internal passages
- Dimensional control

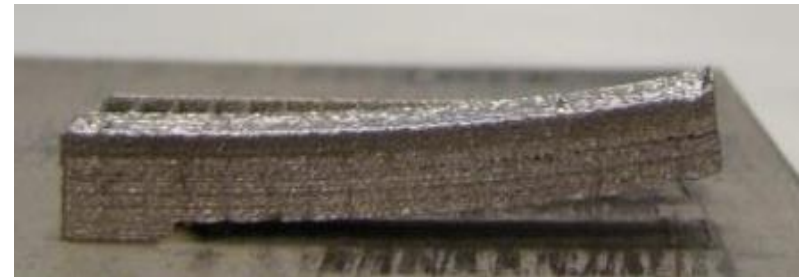
- **SLM Disadvantages:**

- Produces large thermal gradients that produce undesirable residual stress
- Residual stress (RS) causes thermal cracking and build distortion in AM which results in build failure

**Objective: Develop methods to measure and control residual stress in SLM builds**



Frazier et al. (2014)



Ti64 AM build distortion



# Background: Residual Stresses in SLM



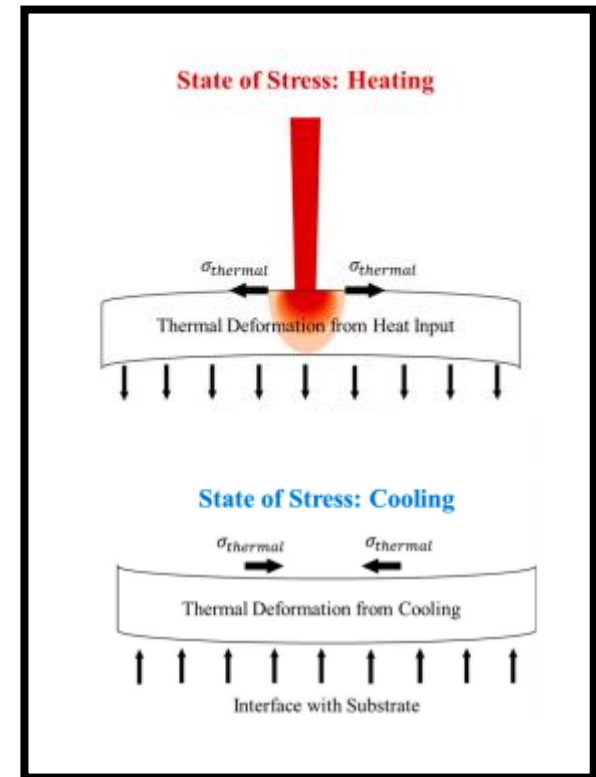
*A Century of Scientific Excellence. We Make it Possible!*

## • Prior Literature Observations:

- Melt pool cooling rate can be tailored to reduce residual stress
- Process parameters (e.g. laser power, scan speed, hatch spacing, dwell time, and scan strategy) can affect the evolution of residual stress
- Substrate preheating and support structure can reduce residual stress

## • Previous work fails to establish:

- The effect of substrate geometry, thickness, confinement, and overhang on residual stress
- The effect of process parameters on residual stress
- The effect of prior build-plate condition on AM residual stress
- Effect of measurement method (e.g. XRD, Hole Drilling, Contour Method, and Layer removal method) on residual stress



Farrington et. al (2017)



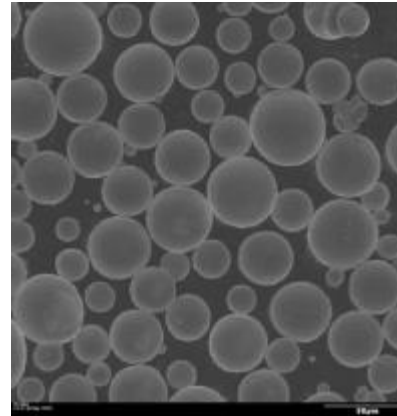
# Program Material & AM System



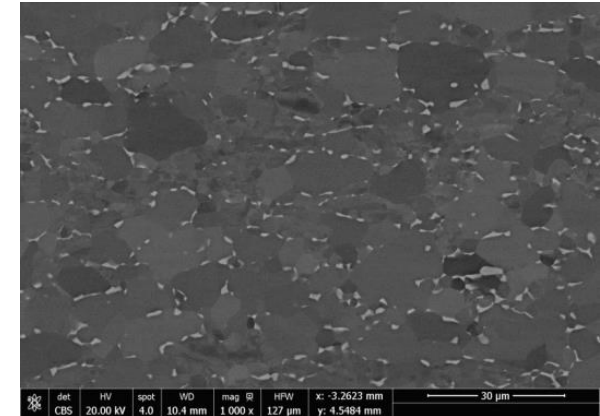
*A Century of Scientific Excellence. We Make it Possible!*

## Program Material

- Ti-6Al-4V substrate and Ti-6Al-4V AM powder
- Average diameter of Ti64 powder particles: 23.4  $\mu\text{m}$
- As-received substrate microstructure:  
93% alpha and 7% beta by area fraction
  - Substrates cut from a 28" x 24" plate that had a thickness of 5/16"
  - Substrates dimensions were 76.2 mm x 76.2 mm x 7.93 mm and 25.4 mm x 25.4 mm x 7.93 mm



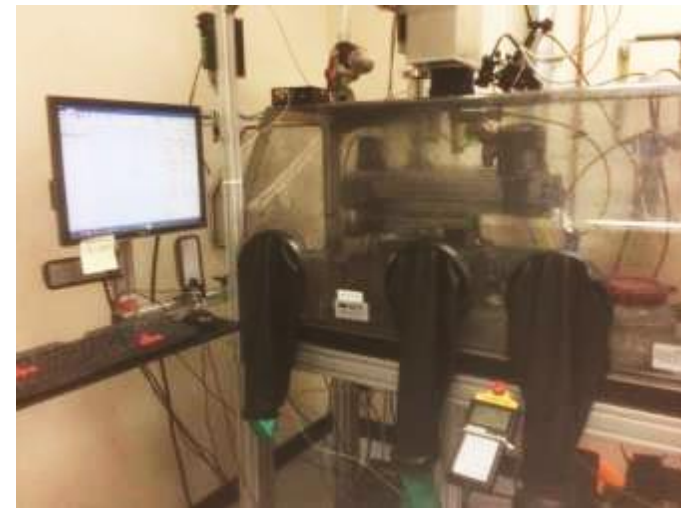
As-Received powder



Microstructure of as-received Ti64 substrate

## SLM System

- IPG 500 W Laser with a spot size of 50  $\mu\text{m}$
- F-theta lens with 6 inch focal length
- AM system enables customized process design

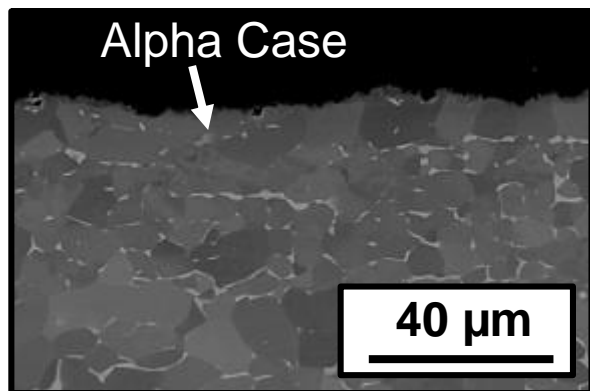


UTC SLM AM system

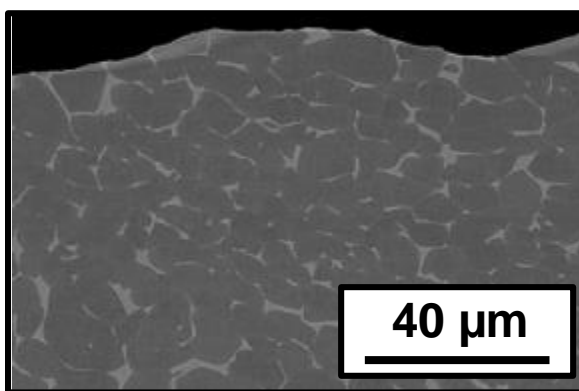
# Initial Substrate Heat Treatments to Eliminate Residual Stresses



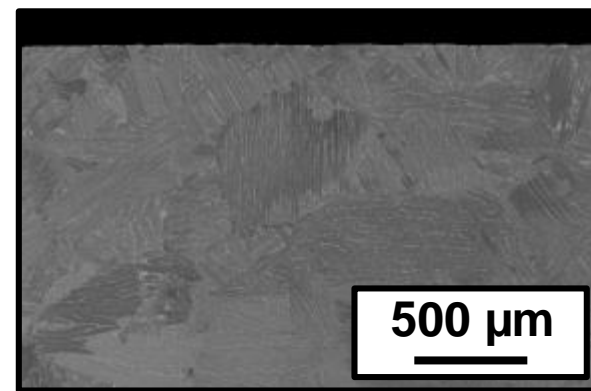
*A Century of Scientific Excellence. We Make it Possible!*



Alpha/Beta Furnace HT

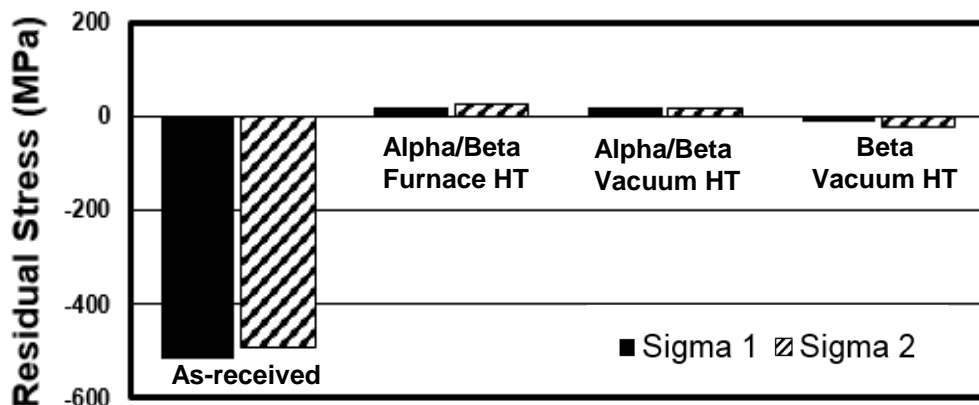


Alpha/Beta Vacuumed HT

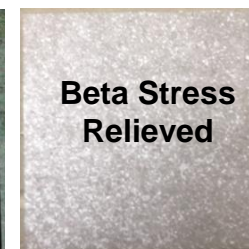
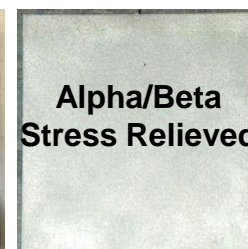


Beta Vacuum HT

## Residual Stress on Substrate Surface



**Furnace Heat Treatment:**  
954°C/1hr + furnace cool  
**Vacuum Heat Treatment:**  
927°C/1hr + cool at 100 °F/hr





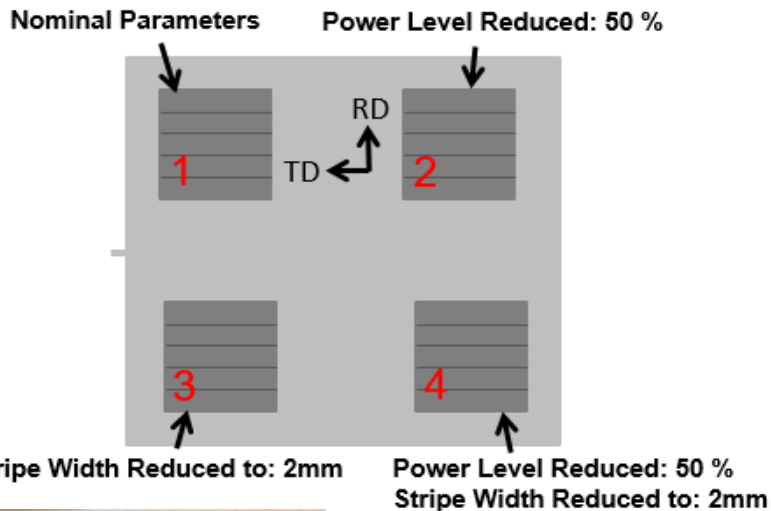
# DoE for Laser Glaze, Substrate Condition, and Build Volume AM Builds



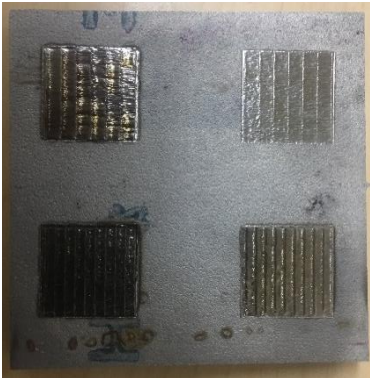
*A Century of Scientific Excellence. We Make it Possible!*

## Build plan for Laser Glazes on 76.2 mm x 76.2 mm substrates

## Build Plan for Various Build Volumes on 76.2 mm x 76.2 mm



- AM Build Size: 76.2 mm x 76.2 mm x 1.6 mm
- AM Build Size: 50.8 mm x 50.8 mm x 1.6 mm
- AM Build Size: 25.4 mm x 25.4 mm x 1.6 mm



- Substrate Conditions:**
- Alpha/Beta Vacuum HT
  - Beta Vacuum HT
  - Alpha/Beta Furnace HT
  - As-received



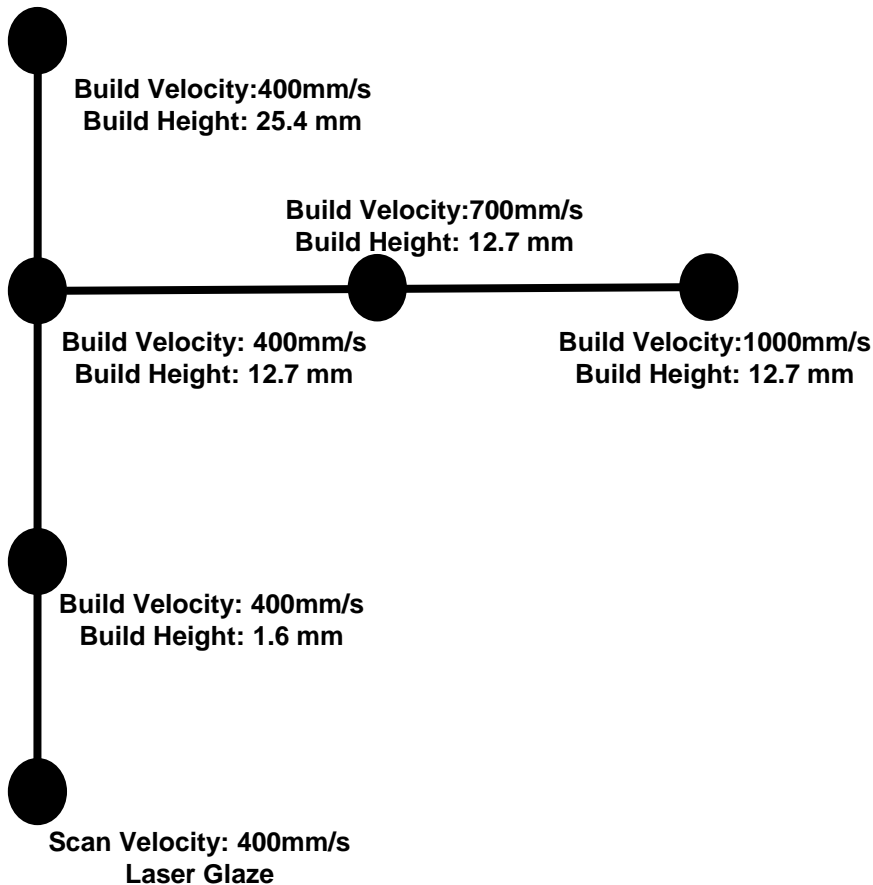


# DoE for (25.4 x 25.4 x *h*)mm AM Builds

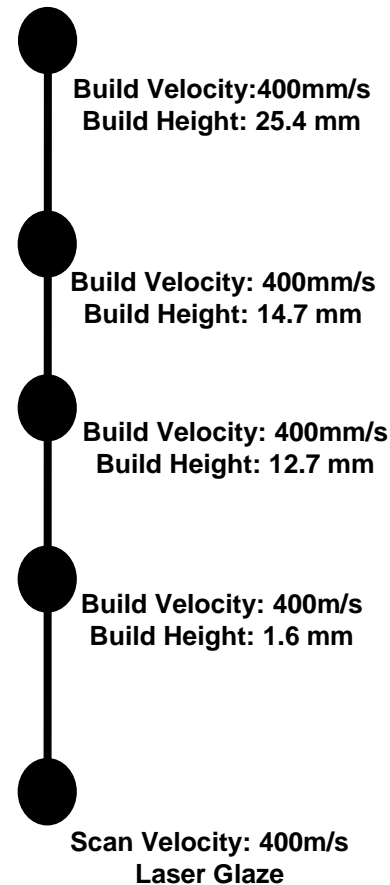


*A Century of Scientific Excellence. We Make it Possible!*

**Build plan for AM samples on 76.2 mm x 76.2 mm substrates**



**Build plan for AM samples on 25.4 mm x 25.4 mm substrates**





# Results



*A Century of Scientific Excellence. We Make it Possible!*

## Surface RS Measurements

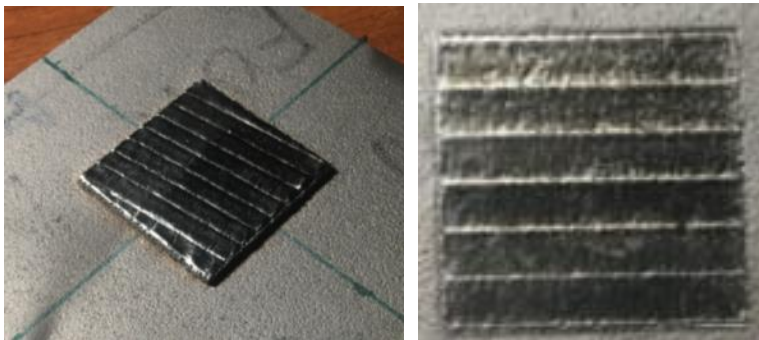
- XRD Measurements
- Hole Drilling Measurements
- XRD vs. Hole Drilling Measurements

## Subsurface RS Measurements

- Layer Removal Method

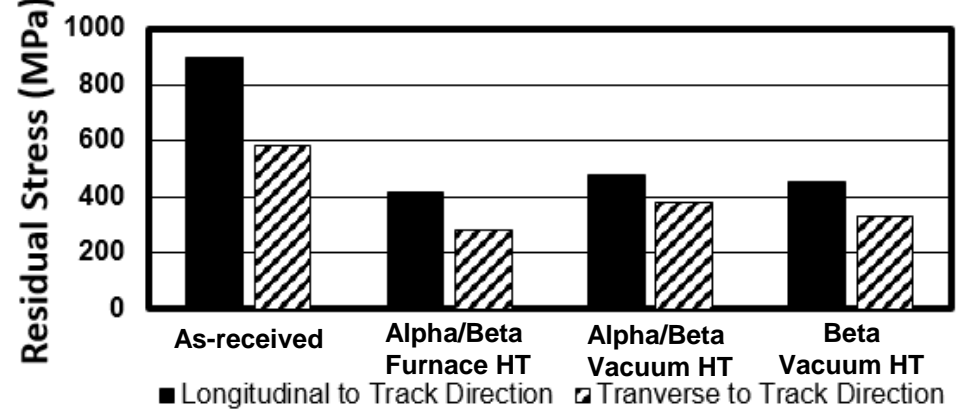
*A Century of Scientific Excellence. We Make it Possible!*

- Largest measured stresses were always parallel to the laser track direction
- Initial substrate stress **does affect** AM build surface residual stress
- Higher laser power and smaller stripe width decreased surface residual stress

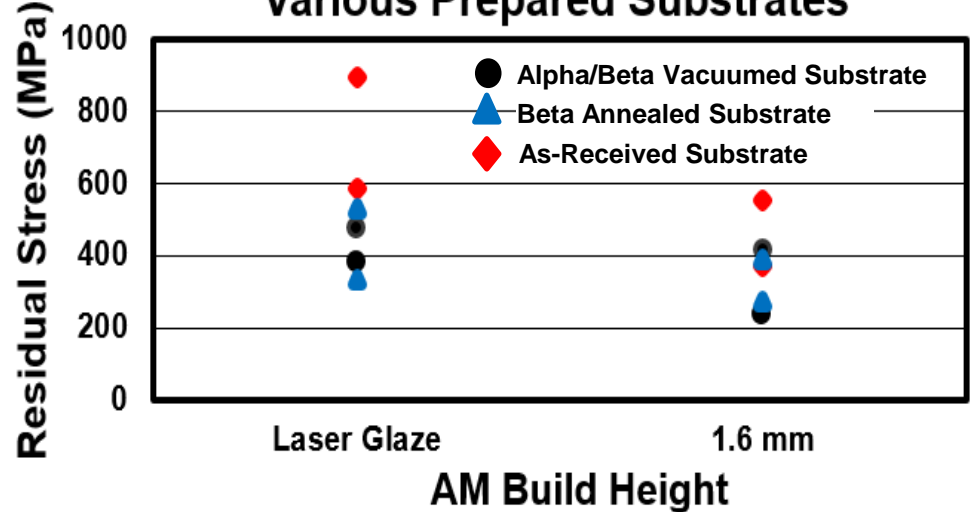


1.6 mm AM build and laser glaze

## Optimal Parameters Laser Glaze

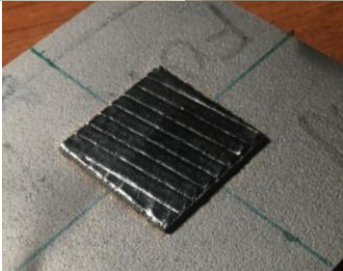
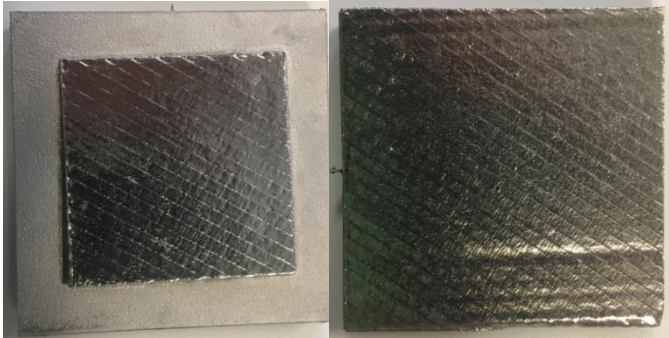


## Various Prepared Substrates

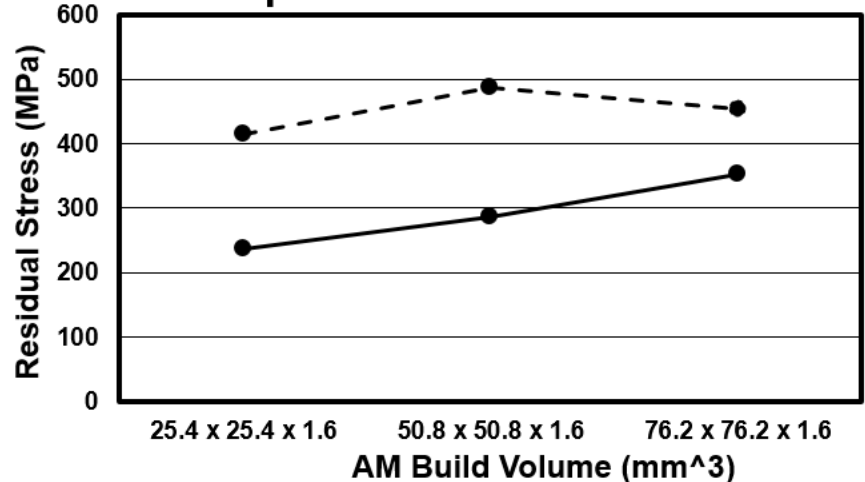


*A Century of Scientific Excellence. We Make it Possible!*

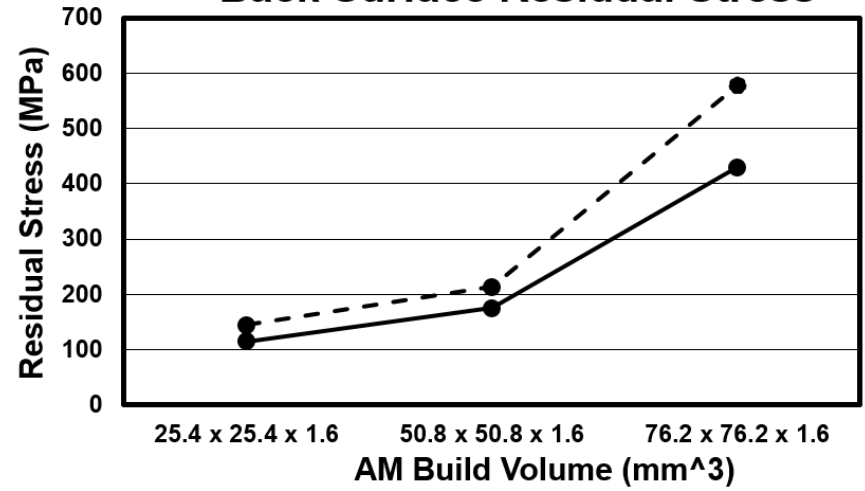
- Largest measured stresses were always parallel to laser track direction
- Back surface residual stress increased as AM build volume increased
- Substrate distortion increased as AM build volume increased



**Top Surface Residual Stress**



**Back Surface Residual Stress**





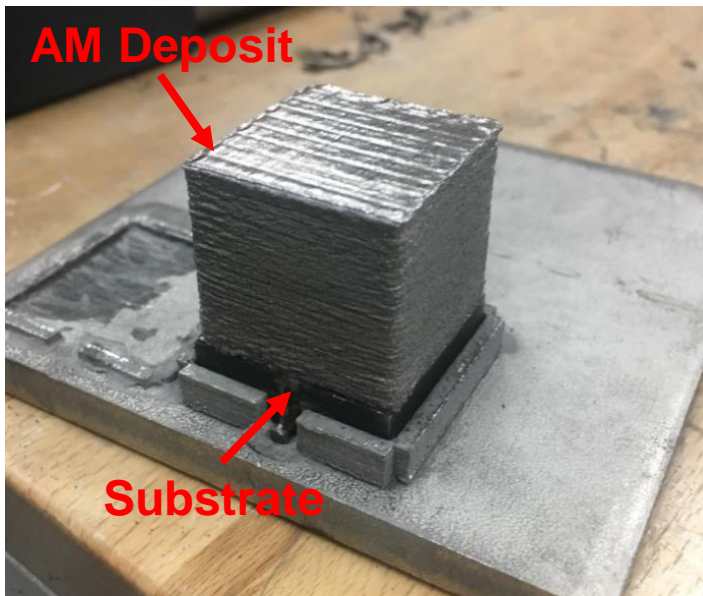
# Effect of Substrate with no Overhang on XRD RS



*A Century of Scientific Excellence. We Make it Possible!*

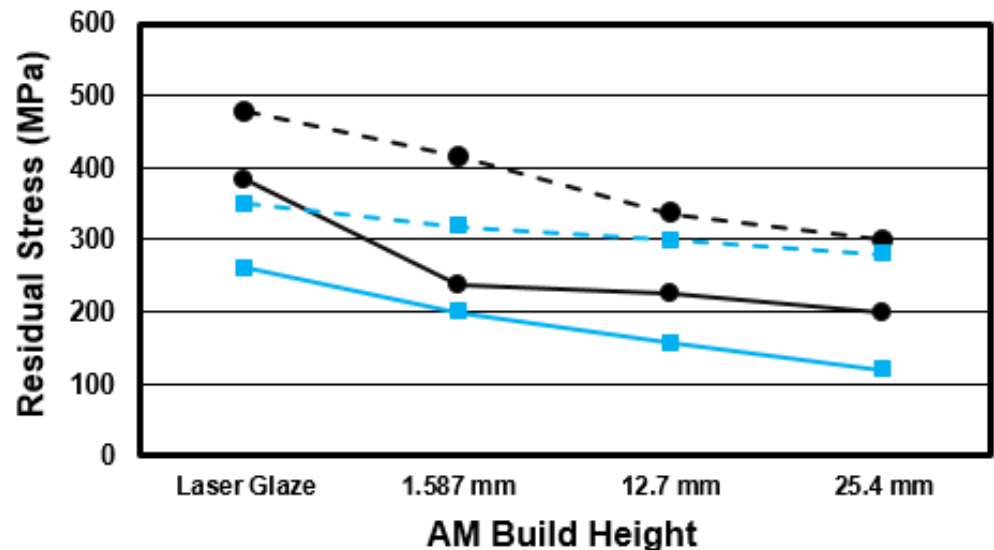
- Principal stresses were parallel and perpendicular to the laser track direction with respect to the *final* deposited layer
- AM builds fabricated on **substrates with no overhang exhibited lower top surface and substrate backside residual stress compared to substrate with overhang**

- Top Surface Residual Stress on 76.2 mm x 76.2 mm x 7.93 mm Substrate
- Top Surface Residual Stress on 25.4 mm x 25.4 mm x 7.93 mm Substrate



AM build with no substrate overhang

## AM Builds on Stress Relieved Substrates



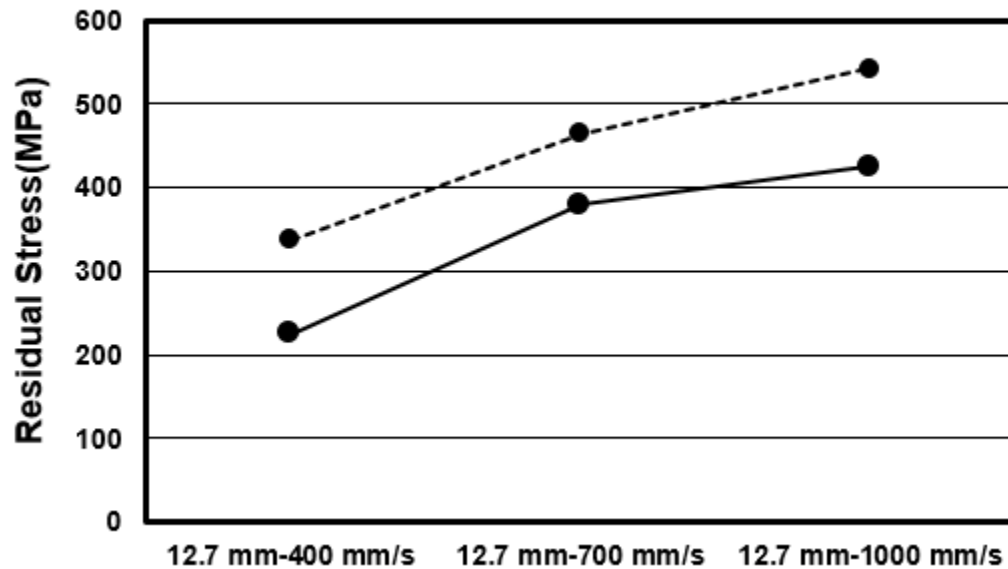


# Effect of Scan Speed on XRD RS



*A Century of Scientific Excellence. We Make it Possible!*

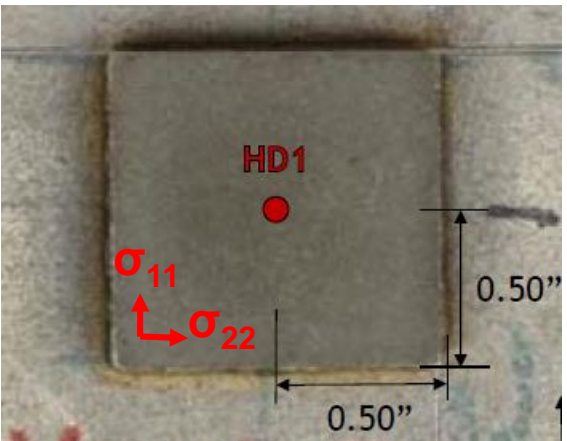
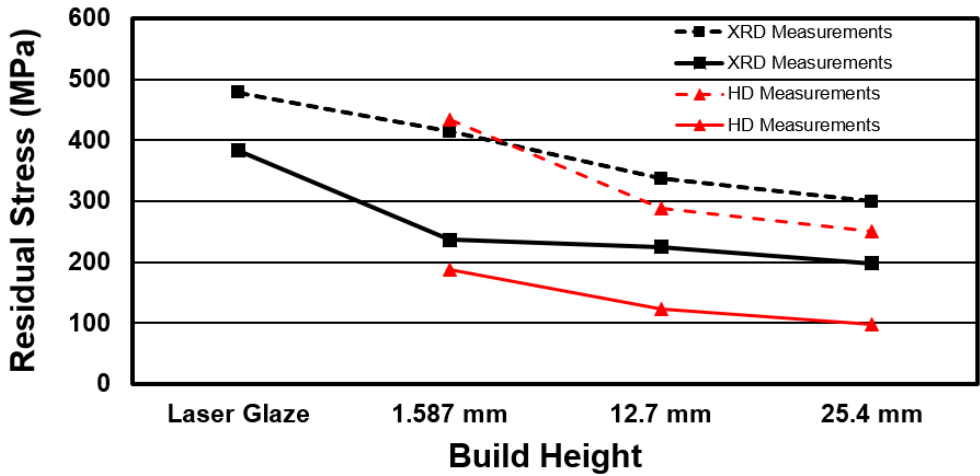
## Top Surface Residual Stress



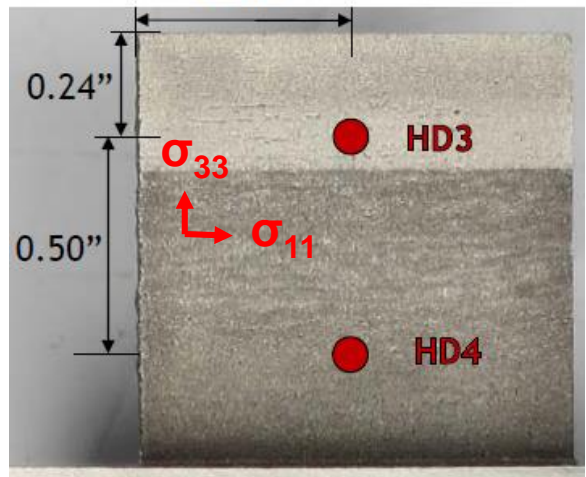
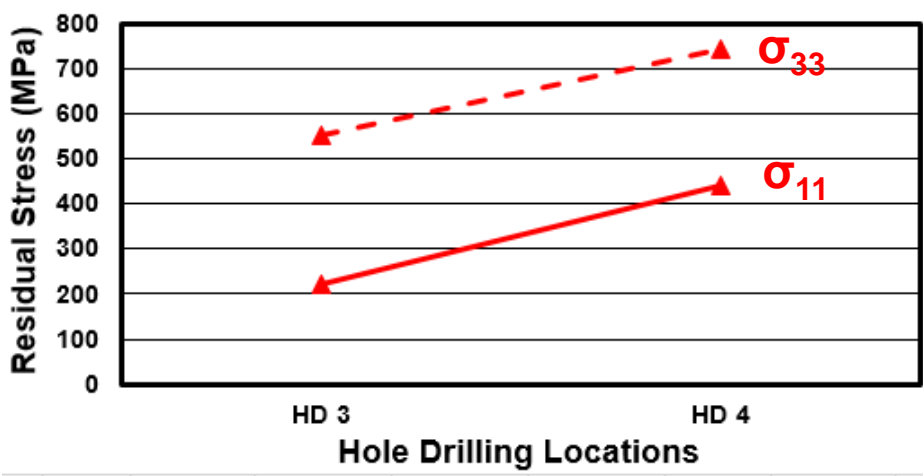
**Top surface residual stress increased as scan speed increased**

*A Century of Scientific Excellence. We Make it Possible!*

**Top Surface Measurements XRD Vs. Hole Drilling**



**Side Surface Residual Stress**



Hole Drilling Locations on AM Deposits

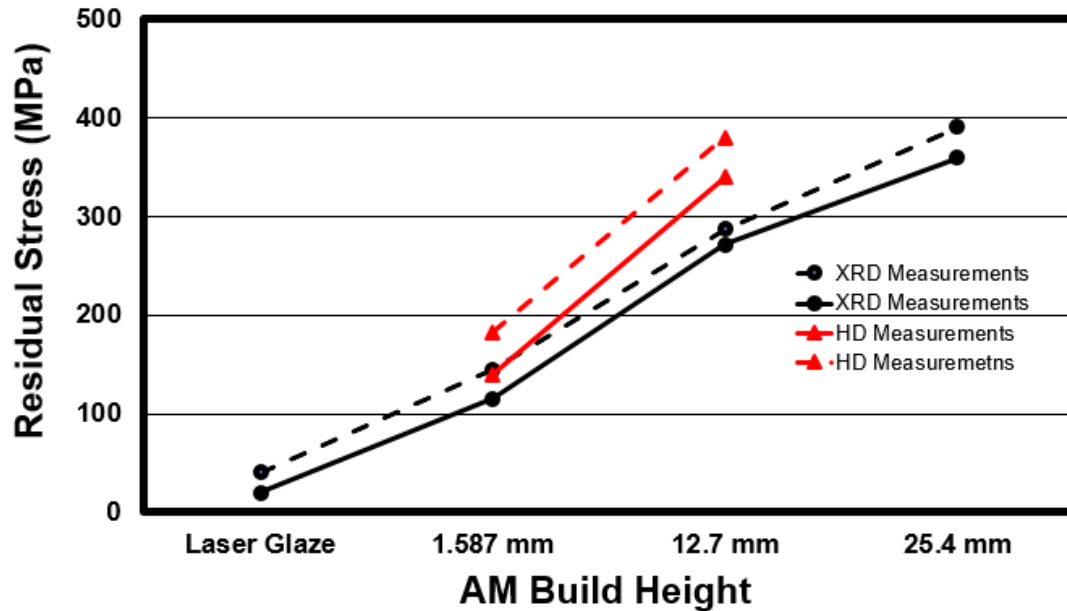


# Hole Drilling RS Measurements



*A Century of Scientific Excellence. We Make it Possible!*

### Substrate Back Surface Residual Stress

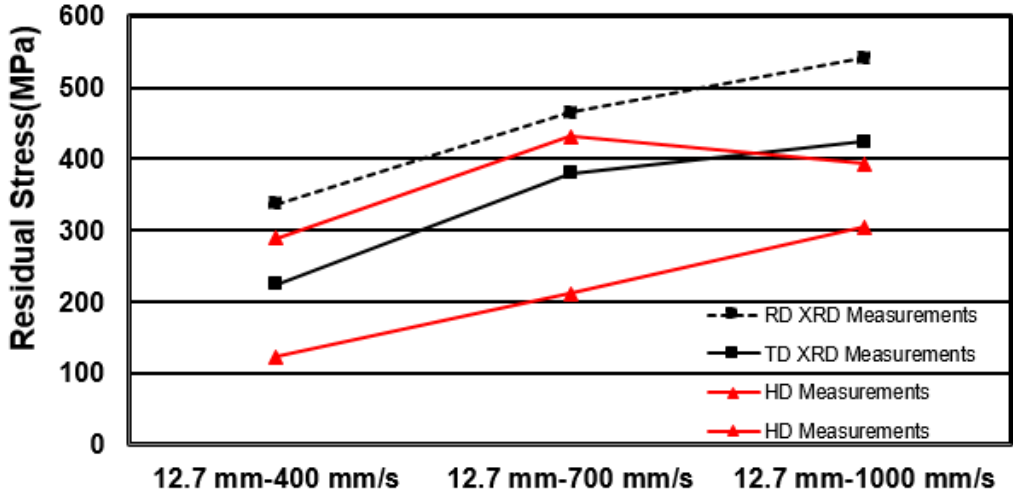


Hole Drilling Location on Substrate Back Surface

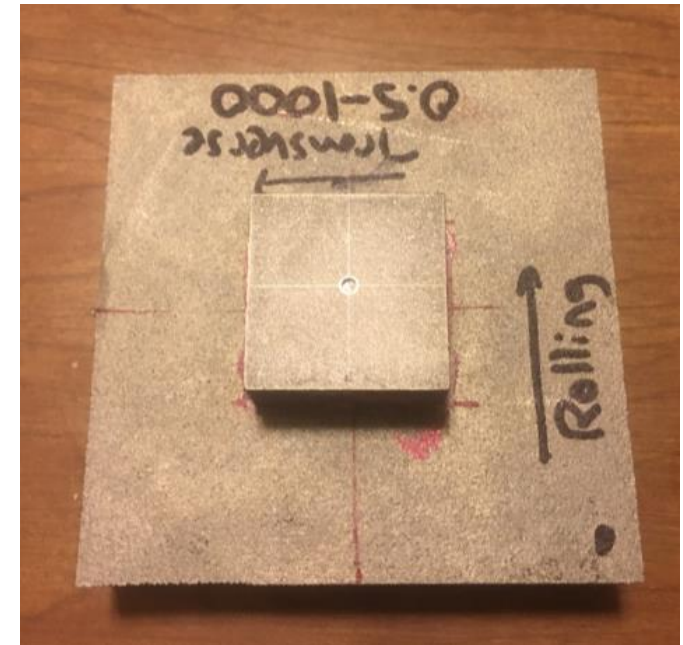
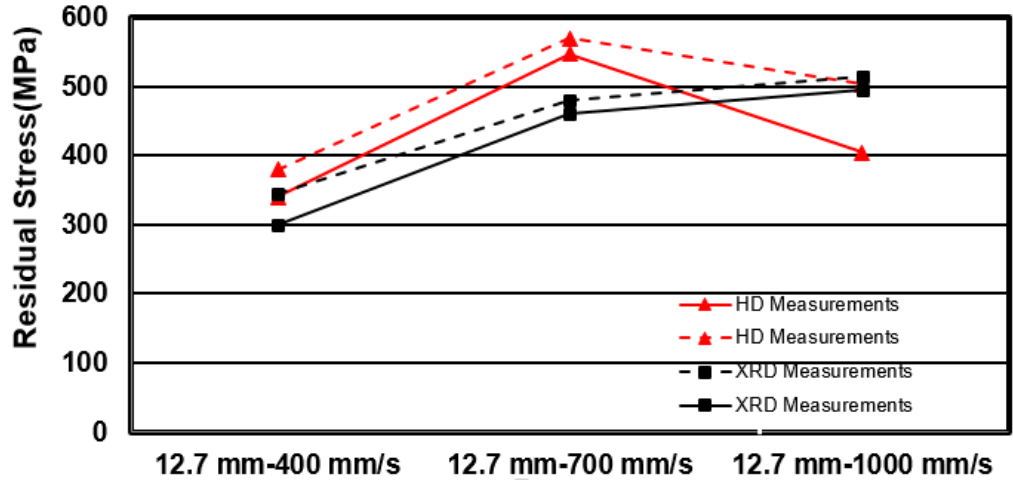


*A Century of Scientific Excellence. We Make it Possible!*

## Top Surface Residual Stress



## Backside Substrate Surface Residual Stress



Hole Drilling Locations on AM Deposits



# Results



*A Century of Scientific Excellence. We Make it Possible!*

## Surface RS Measurements

- XRD Measurements
- Hole Drilling Measurements
- XRD vs. Hole Drilling Measurements

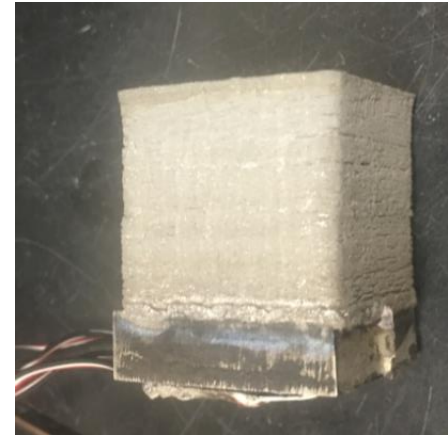
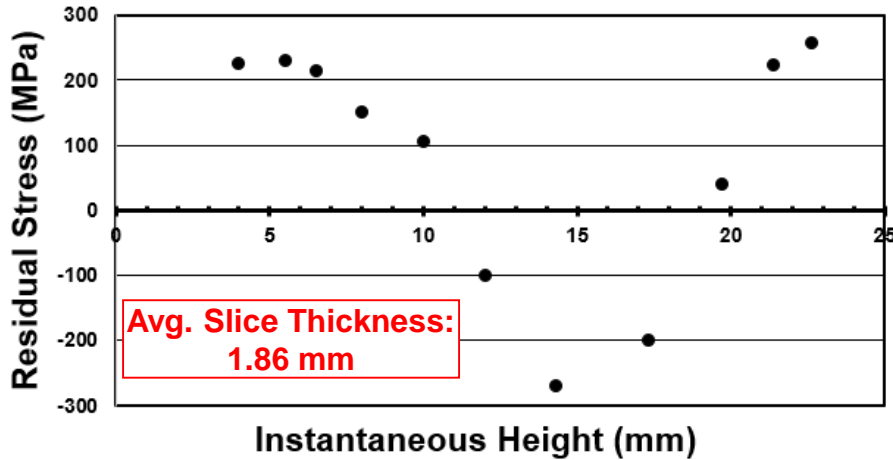
## Subsurface RS Measurements

- Layer Removal Method

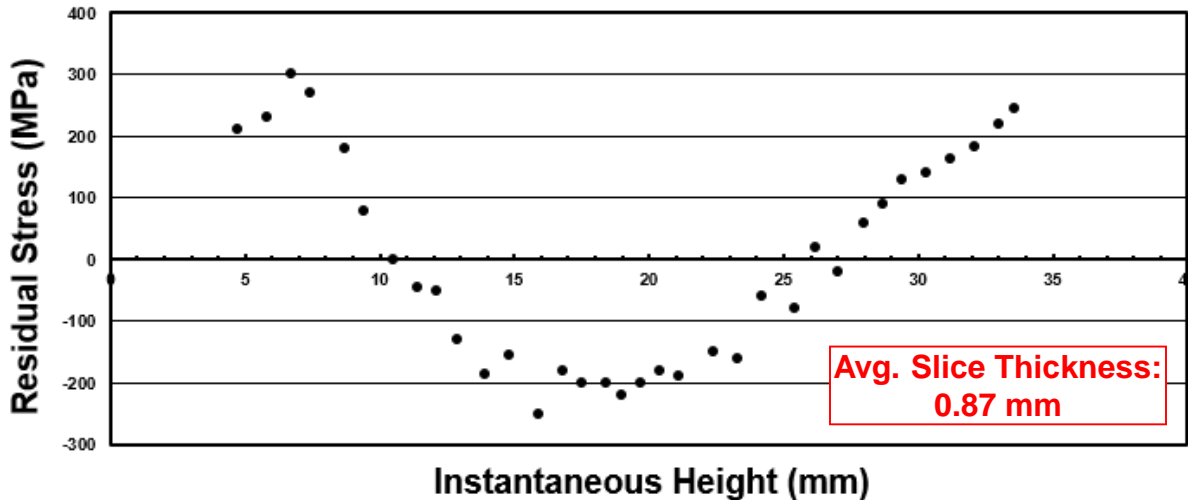
# Layer Removal Method

*A Century of Scientific Excellence. We Make it Possible!*

## 14.7 mm AM Build



## 25.4 mm AM Build



Layer-removal-method sample



# Conclusions

*A Century of Scientific Excellence. We Make it Possible!*

- **Higher laser power, lower scan speed, smaller stripe width, reduction in substrate overhang, reduction in plan area all decrease top-surface residual stress**
- **There are similarities and differences among the different measurement techniques**



# Future Work



*A Century of Scientific Excellence. We Make it Possible!*

- **Determine x-ray elastic constants for Ti64 substrates and additively manufactured Ti64**
- **Determine texture of AM builds (EBSD)**
- **Determine Knoop hardness yield loci to assess plastic anisotropy**



# Questions?



*A Century of Scientific Excellence. We Make it Possible!*